

Declaration For Patent Application

特許出願宣言書

Japanese Language Declaration

日本語宣言書

下記の氏名の発明者として、私は以下の通り宣言します。

下記の名称の発明に関して請求範囲に記載され、特許出願している発明内容について、私が最初かつ唯一の発明者（下記の氏名が一つの場合）もしくは最初かつ共同発明者（下記の名称が複数の場合）であると信じています。

上記発明の明細書は、

本書に添付されています。
 ____ 月 ____ 日に提出され、米国出願番号または特

許協定条約国際出願番号を

_____ とし、

（該当する場合）_____ に訂正されました。

私は、特許請求範囲を含む上記訂正後の明細書を検討し、内容を理解していることをここに表明します。

私は、連邦規則法典第37編第1条56項に定義されるとおり、特許資格の有無について重要な情報を開示する義務があることを認めます。継続願書一部分を含む資料案内は前回の願書記入日から、米国願書または国際特許協定条約継続願書記入日の間に入手できます。

As a below-named inventor, I hereby declare that:

I believe I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural names are listed below) of the subject matter which is claimed and for which a patent is sought on the invention entitled.

COMPOSITION FOR FORMING SILICON-ALUMINUM FILM, SILICON-ALUMINUM FILM AND METHOD FOR FORMING THE SAME

the specification of which

is attached hereto.
 was filed on December 24, 2003

as United States Application Number or PCT International Application Number

PCT/JP03/16579 and was amended on
_____ (if applicable)

I hereby state that I have reviewed and understand the contents of the above-identified specification, including the claims, as amended by any amendment referred to above.

I acknowledge the duty to disclose information which is material to patentability as defined in Title 37, Code of Federal Regulations, § 1.56, including for continuation-in-part applications, material information which became available between the filing date of the prior application and the national or PCT International filing date of the continuation-in-part application.

私は、私自身の知識に基づいて本宣言書中で私が行なう表明が真実であり、かつ私の入手した情報と私の信じるところに基づく表明が全て真実であると信じていること、さらに故意になされた虚偽の表明及びそれと同等の行為は米国法典第18編第1001条に基づき、罰金または拘禁、もしくはその両

方により処罰されること、そしてそのような故意による虚偽の声明を行なえば、出願した、又は既に許可された特許の有効性が失われることを認識し、よってここに上記のごとく宣誓を致します。

I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

単独発明者または第 1 の共同発明者の氏名		Full name of sole or first inventor Yasuaki YOKOYAMA (deceased)
国籍		Citizenship of First Joint Inventor JAPAN
発明者の署名	日付	<p>Inventor's signature:</p> <p>Legal Representative of first joint inventor</p> <p>We, Michiko YOKOYAMA, Naomi SHINODA, and Risa YOKOYAMA, are the heirs and legal representative of Yasuaki YOKOYAMA (deceased). We attest, upon information and belief, that the aforementioned facts are true.</p> <p>Signature of Michiko YOKOYAMA</p> <p><u>Michiko Yokoyama</u></p>
		Date June 18, 2005
		<p>Residence of Michiko YOKOYAMA: Mie, JAPAN</p> <p>Citizenship of Michiko YOKOYAMA: JAPAN</p> <p>Mailing Address of Michiko YOKOYAMA: 35-15, Oukadai 2-chome, Yokkaichi-shi, Mie, JAPAN</p>
		<p>Signature of Naomi SHINODA</p> <p><u>Naomi Shinoda</u></p>
		Date June 19, 2005
		<p>Residence of Naomi SHINODA: Aichi, JAPAN</p> <p>Citizenship of Naomi SHINODA: JAPAN</p> <p>Mailing Address of Naomi SHINODA: Kaniehommachi Tanowari 8-3, Kanie-cho, Ama-gun, Aichi, JAPAN</p>
		<p>Signature of Risa YOKOYAMA</p> <p><u>Risa Yokoyama</u></p>
		Date June 18, 2005
		<p>Residence of Risa YOKOYAMA: Mie, JAPAN</p> <p>Citizenship of Risa YOKOYAMA: JAPAN</p> <p>Mailing Address of Risa YOKOYAMA: 35-15, Oukadai 2-chome, Yokkaichi-shi, Mie, JAPAN</p>

第 2の共同発明者の氏名	Full name of second joint inventor, If any Yasuo MATSUKI	
第 2の共同発明者の署名	日付	Second inventor's signature Date <i>Yasuo Matsuki</i> June 14, 2005
住所	Residence Chuo-ku, Tokyo, JAPAN	
国籍	Citizenship JAPAN	
郵便の宛先	Mailing Address c/o JSR Corporation, 6-10, Tsukiji 5-chome, Chuo-ku, Tokyo 104-0045 JAPAN	

GENERAL POWER OF ATTORNEY TO PROSECUTE APPLICATIONS BEFORE THE
UNITED STATES PATENT AND TRADEMARK OFFICE

I hereby appoint:

Practitioners associated with the Customer Number

22850

as attorney(s) or agent(s) to represent the undersigned before the United States Patent and Trademark Office (USPTO) in connection with any and all patent applications assigned only to the undersigned according to the USPTO assignment records or assignment documents attached to this form in accordance with 37 CFR 3.73(b).

Assignee Name and Address:

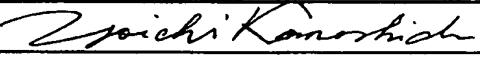
Name: JSR Corporation

Address: 6-10, Tsukiji 5-chome, Chuo-ku, Tokyo
104-0045 JAPAN

A statement under 37 CFR 3.73(b) is attached.

SIGNATURE OF ASSIGNEE OF RECORD

The individual whose signature and title is supplied below is authorized to act on behalf of the assignee

Signature		Date: December 16, 2004
Name	Yoichi Kamoshida	Telephone:
Title	General Manager, Intellectual Property Department	

101542358

JC17 Rec'd PCT/PTO 14 JUL 2005

STATEMENT UNDER 37 CFR 3.73(b)

Applicant/Patent Owner: Yasuaki YOKOYAMA, et al.

New U.S. PCT Application based on

Application No./Patent No.: PCT/JP03/16579 Filed/Issue Date: Herewith

Entitled: COMPOSITION FOR FORMING SILICON-ALUMINUM FILM, SILICON-ALUMINUM FILM AND METHOD

Entitled: FOR FORMING THE SAME

JSR Corporation, a Corporation
(Name of Assignee) (Type of Assignee, e.g., corporation, partnership, government agency, etc.)

States that it is:

1. the assignee of the entire right, title, and interest; or
2. an assignee of less than the entire right, title and interest.

The extent (by, percentage) of its ownership interest is _____ %

in the patent application/patent identified above by virtue of an assignment from the inventor(s) of the patent application/patent identified above. A copy of the assignment is attached.

The undersigned (whose title is supplied below) is authorized to act on behalf of the assignee.

Surinder Sachar

Surinder Sachar
Registration No. 34,423

July 14 2005

Signature

Date

Norman F. Oblon

703-413-3000

Printed or Typed Name

Telephone Number

24,618

Registration Number